

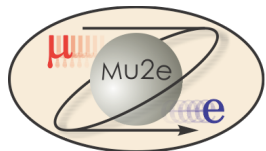
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# Discussion on the Mu2e Laser System

S.Miscetti

MUSE networking meeting: Mu2e vs g-2 Calibration systems

4 August 2016



# EMC Calibration Team

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Calorimeter experience from Crystal Ball, Mark II, BaBar, SuperB  
BaBar source calibration system was Caltech responsibility

- Frank Porter (Caltech):
  - EMC Calibration L3 Manager
- Kevin Flood (Caltech):
  - Engineering physicist, source
- Jason Trevor (Caltech):
  - Engineer, source
- Bertrand Echenard (Caltech):
  - Simulation, source
- Pasha Murat (Fermilab):
  - Decays in orbit,  $\pi^+ \rightarrow e \nu$
- Marco Cordelli (INFN-LNF)
  - Laser system
- Stefano Miscetti (INFN-LNF)
  - Laser system

# Scope 475.7.6 - Calorimeter calibration

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This task contains all aspects needed to build an operative calibration system both with the radioactive source for the determination of the absolute scale and with the laser system for a monitor of the photo-sensor gains. The laser system will be provided by INFN as in-kind contribution.

# Requirements

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The EMC requirements are described in docdb-864

R1) Online calibration sufficient for calorimeter trigger, online diagnostics

(R2) Precision commensurate with calorimeter resolution requirement of  $\text{FWHM}/2.35 \sim 5\%$  at 100 MeV

(R3) Absolute precision and stability better than 1%

(R4) Independent calibration of each crystal

(R5) Track time dependence

(R6) Perform (source) calibration of entire calorimeter in  $\sim 10$  minutes

(R7) Timing resolution better than 0.5 ns (driven by PID)

(R8) Position resolution  $< 1$  cm

# Design choice for calorimeter calibration

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- Unchanged since CD-2 (2014) except for adjustments for change from BaF2 to CsI
  - Laser frequency changed from UV to green

# Our solution to calorimeter calibration requirements

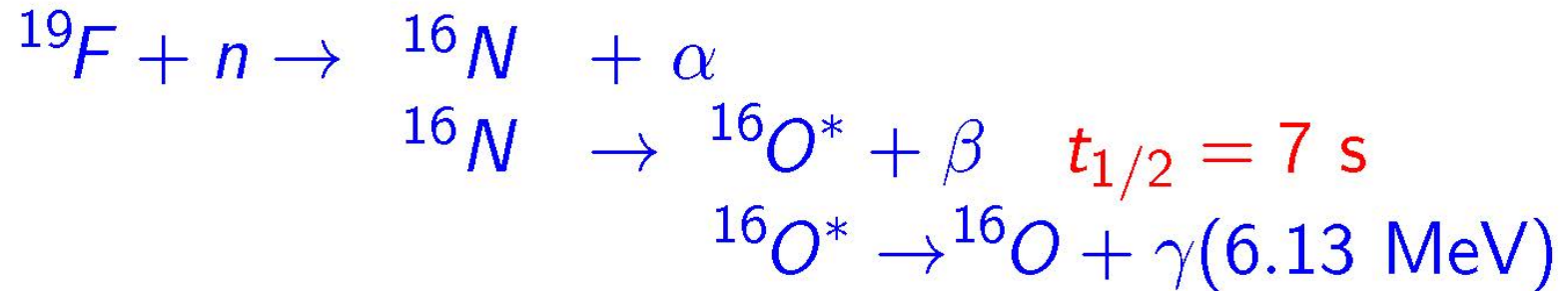
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- Pre-insertion calibration with 6 MeV source
- Weekly crystal-by-crystal calibration with 6 MeV source
- Monitor readout on shorter time scale with LASER pulsing system
- Higher energy with DIOs (Decays In Orbit)
  - Interpolation and extrapolation with source
  - Tracker can be used, low field for outer crystals
  - Absolute spectrum (at lower fields)
  - Check of MC extrapolation
- Cosmic rays as independent check
- $\pi^+ \rightarrow e^+ \nu_e$  as optional independent check (70 MeV  $e^+$ )
- Monitor electronics gains with pulser
- Monitor temperatures

# 6 MeV source calibration

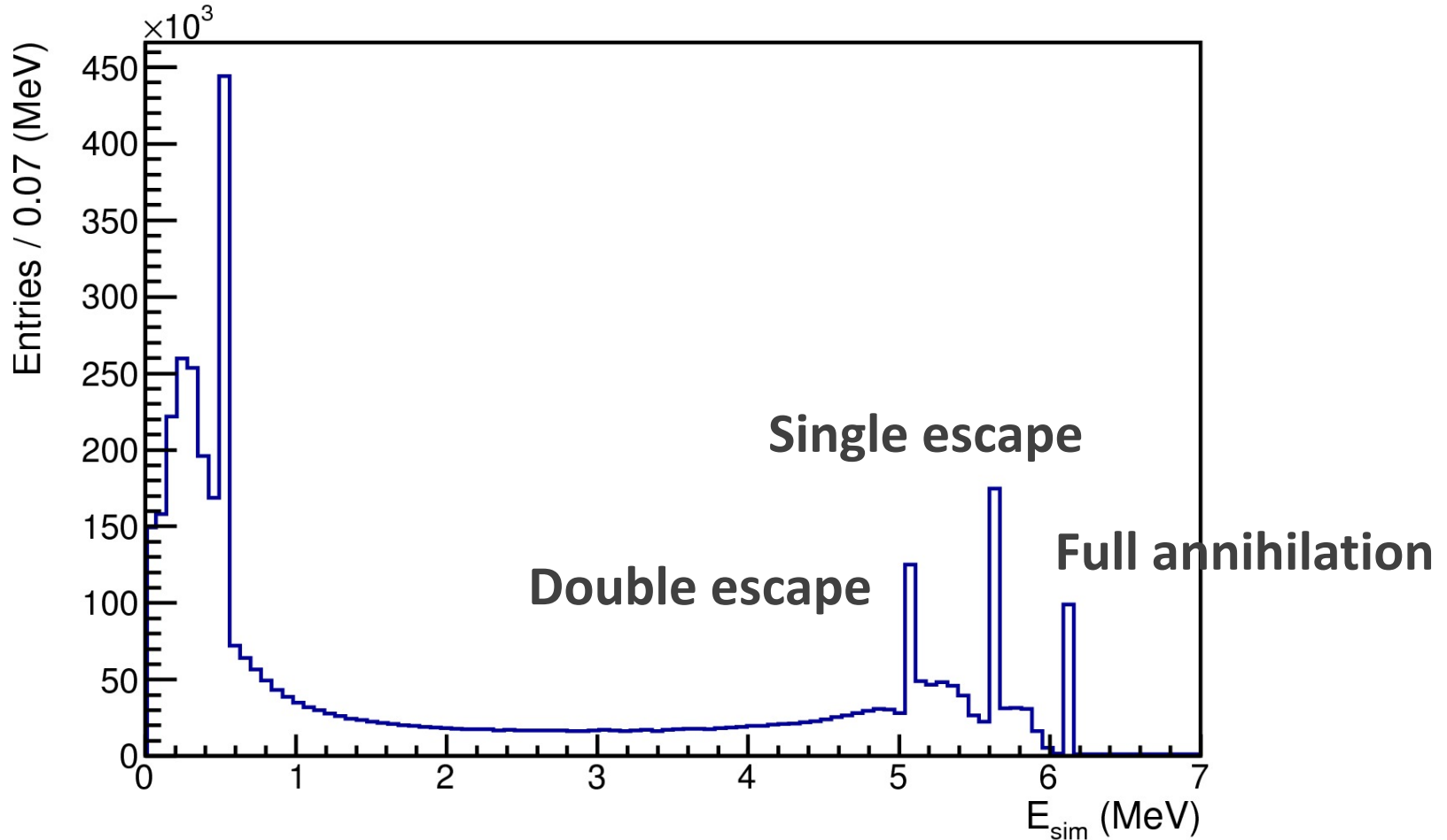
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Reaction yielding 6.13 MeV photons is:



- Low energy neutrons from a DT generator irradiate Fluorinert™ fluid outside detector
- Activated liquid pumped through pipes to front faces of crystals
- DT neutron generator d+t -> n(14.2 MeV):  $10^9$  n/s (ING-07)

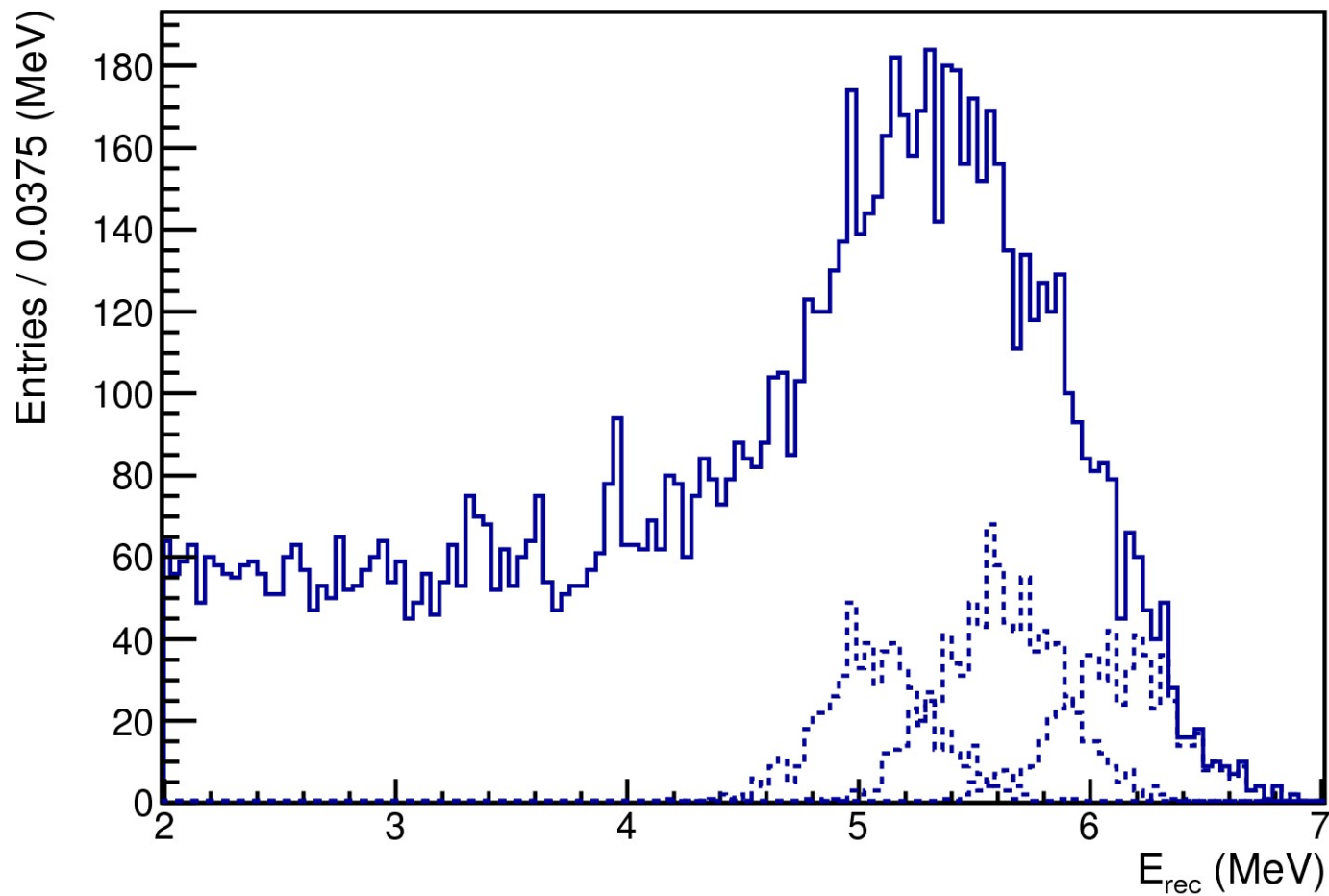
## Energy of each crystal hit at the generator level



Full annihilation, single and double escape peaks + Compton



# Spectrum corresponding to 10,000 calibration photons



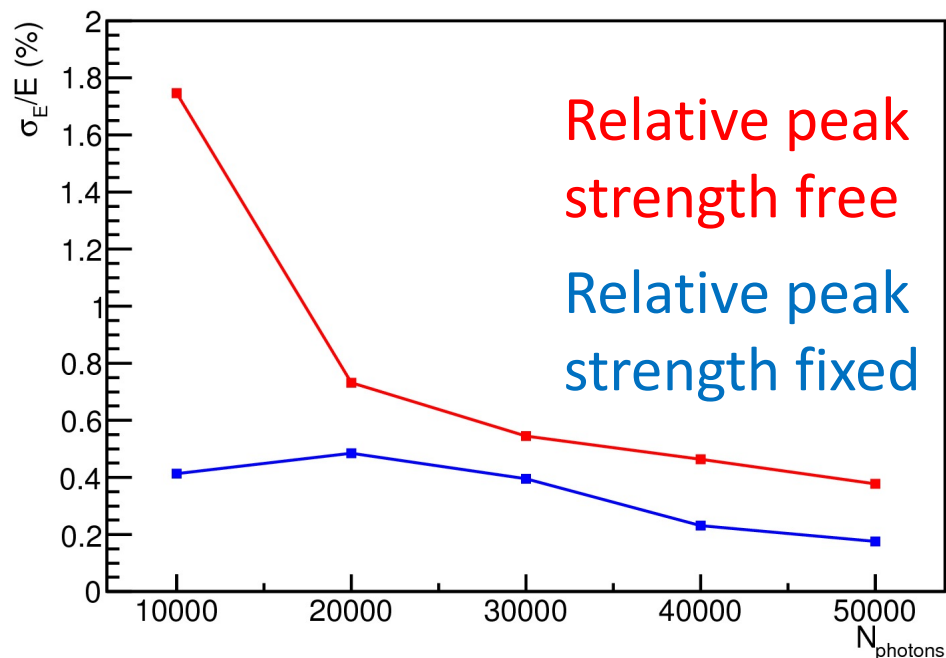
# Performance - Source calibration simulation results

Source rate is  $\sim 10,000$  entries/crystal/10 min

Precision (%) to have  
10% effect on resolution

Resolution (%)	Calibration precision (%)
3	1.4
4	1.8
5	2.3

## Precision (%)



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# LASER System

# Laser System requirements

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- To keep the timing and energy resolution required we need also a **continuous monitoring of the detector gain and of the timing offsets**.
- **ENERGY:** While absolute energy scale will be provided by weekly calibration with the source, **a control of faster gain changes** (due to irradiation, increase of leakage current or temperature variation) **will be performed to keep the detector equalization constant**. Since we expect slow variation trends, the **relative gain change, at 0.5 % accuracy, can be tracked each hour**.
- **TIMING:** Similarly the determination of channel by channel timing offsets,  $T_0$ , and pulse height dependence, slewing, has to be determined to compensate for small differences on cable lengths, transit times of SIPM response or electronics delays/jitters. **Timing calibration to be kept below few tens of ps**. Final calibration of the timing scale between calorimeter and tracker will be provided “in situ” by means of DIO electrons.

# Laser System specifications

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- Laser system to **have enough power to get light to all 1374 crystals** by means of an optical distribution system and to a **monitoring system that tracks the variation of the Laser light at the source**. We are tuning this system to get a **laser signal with a pulse height equivalent to 100 MeV electrons, 3000 Npe**.
- **The laser has to emit on blue or green wavelengths** to be in a region far from the CsI emission peak (310 nm), to be in a region where transmittance changes due to irradiation are small. This isolates photosensor gain variation.
- **The Laser has to be pulsed with a settable frequency below 100 Hz** by means of an external trigger. During running the Laser will be pulsed at a rate of 0.1 Hz and will be synchronized to be in the “beam-off” region.
- **Laser output to be controlled in amplitude to allow a measurement of the response linearity** for the photosensors and FEE chain.
- **The monitoring system will be based on PIN diodes** in a thermally controlled box

# Laser System Scheme

- ❑ The laser beam intensity is attenuated up to a factor of 10 by a graduated **neutral density filter**
- ❑ The beam will be split, by means of semi transparent mirrors to **8 beams** and **focused by optical lens to 1 mm diameter Fused Silica fibers**. 1/3 of the light will be sent to a 2" diffusing sphere with 3 pin-diodes for monitoring.
- ❑ Eight 60 m long fibers, routed from the counting room to the DS bulkhead brings the light to 8 2" diffusing spheres on the mechanical structure
- ❑ Each sphere, will have 1 pin diode for monitor and 3 bundles of 200  $\mu\text{m}$  silica fibers. Each fiber will be inserted into a lodging in the back of the crystals close to the SIPM holders.
- ❑ Laser Trigger will be synchronized with the DAQ Clock signals and delayed into the beam-off region.

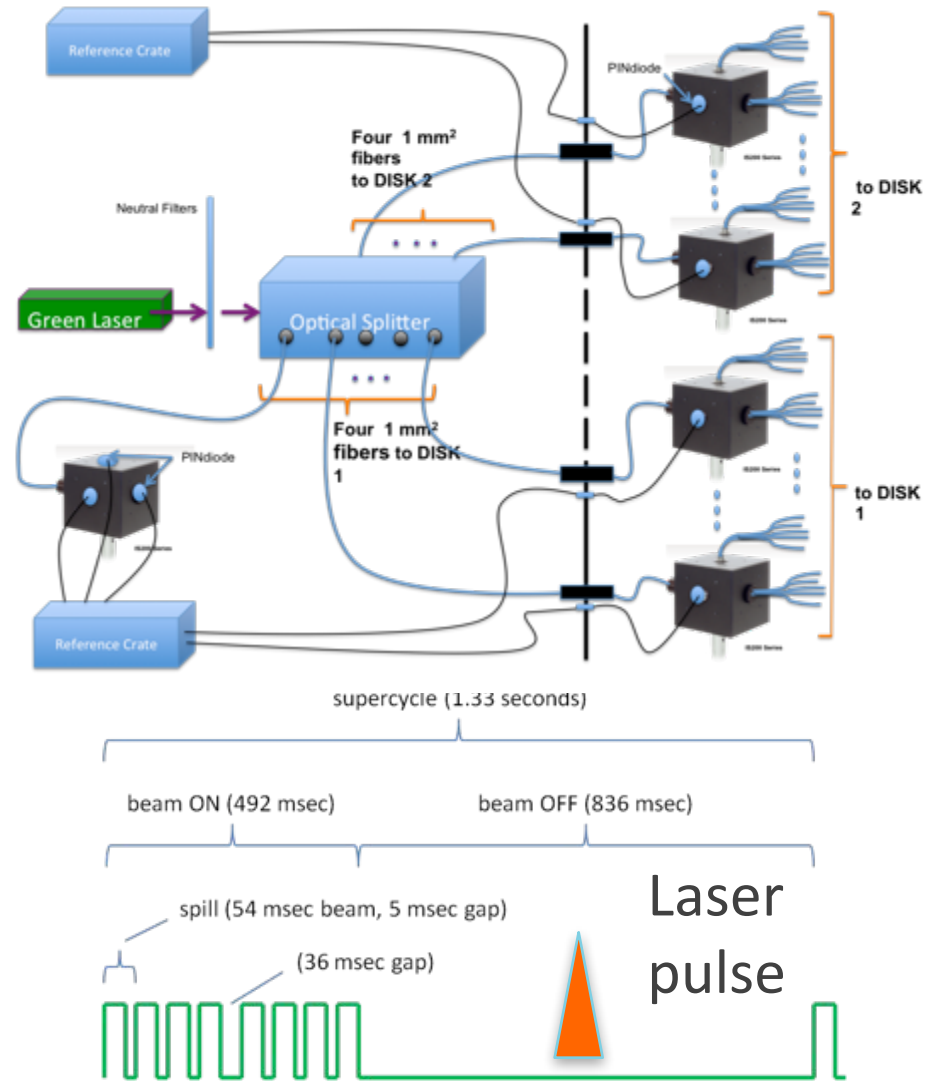


Figure 11.1. Mu2e Beam Structure.

# Laser Model specifications



LaserHead+Laser  
Controller Box  
Diode Pumped Nd:Yag  
Solid-State **Micro Laser**

Table of Typical Micro Laser Models

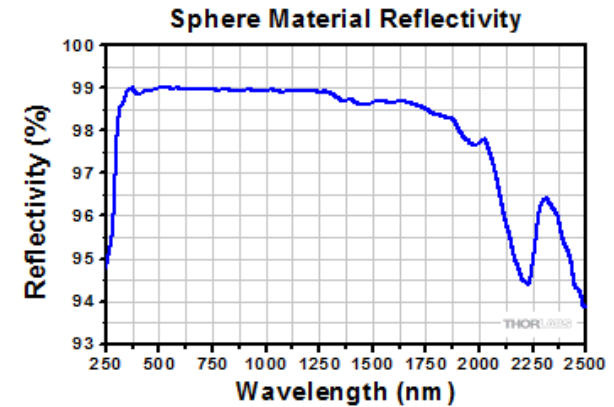
Models	STA-01SH-1	STA-01SH-2	STA-01SH-3	STA-01SH-4	STA-01SH-5
Wavelength, nm			532		
Average output power (max), mW	40	25	50	20	100
Pulse energy, $\mu\text{J}$	4	5	50	0.2	100
Pulse width (FWHM), ns	0.5	< 0.7	0.5	0.5	0.5
Repetition rate (max), kHz	10	5	1	100	1
Beam Profile	$M^2 < 1.1$				
Pulse spectral structure	single longitudinal mode				
Polarization ratio	> 100:1				
Beam Waist diameter inside the laser head $1/e^2$ , $\mu\text{m}^*$	25-200				
Pulse spectrum FWHM, pm	< 5 (near transform limited)				
Pulse to pulse energy stability RMS	< 0.5				
Power stability over six hours**	< $\pm 1.5\%$				
External power supply voltage, V AC	100-240				
Operating temperature, $^{\circ}\text{C}$	15 - 40				
Interfaces	USB, External trigger (TTL rising edge) 1HZ...max repetition rate				
<b>Laser head dimensions:</b>					
diameter, mm	25				
length, mm	76.5				

- Available @ different emission wavelengths  $\rightarrow$  similar product also @ 355 nm.
- It is a good match between very high pulse-energy, good power stability, repetition rate and command from an external trigger. It has been used for the prototype phase.
- 5  $\mu\text{J}$  pulse  $\rightarrow$  equivalent to  $10^{13}$  photons produced at the source.
- Distribution losses are large but light output is more than enough for our purposes.

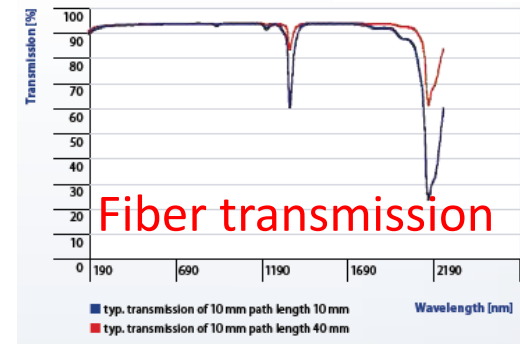
# Light distribution system

## ThorLab-IS200 Sphere

- 1 input, 4 output ports
- PIN-diode ThorLab-SM05PD1A
- 3 Bundle of fibers with SMA connector in the port and final ferrule on each fiber.



- ✓  $L_{\text{output}}/\mu\text{J} = 2 \times 10^{12}$
- ✓  $T(\text{filter+optical}) = 10^{-3}$
- ✓  $T_{\text{fiber}} = 7 \times 10^{-5}$
- ✓  $T_{\text{total}} = 7 \times 10^{-8}$
  
- ✓  $LY = 10^5 \text{ Nphotons/pulse}$
- ✓  $LY (\text{NPE}) = LY \times QE = 3 \times 10^4$



- Fused silica fibers have good transmission for the wavelengths under consideration (from 355 to 500 nm), high reliability and radiation hard for  $\text{Mu}2\text{e}$ .
- **We have tested them up to 90 krad and  $10^{12} \text{ n/cm}^2$  seeing no deterioration.**

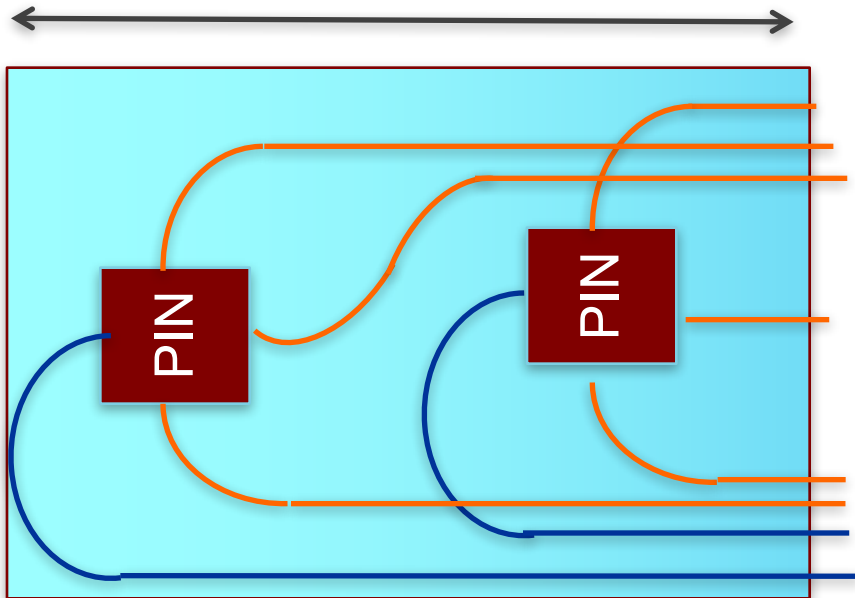


# Fiber routing

After last round of optimization, the number of channels is frozen and we are completing the cable routing for the fibers:

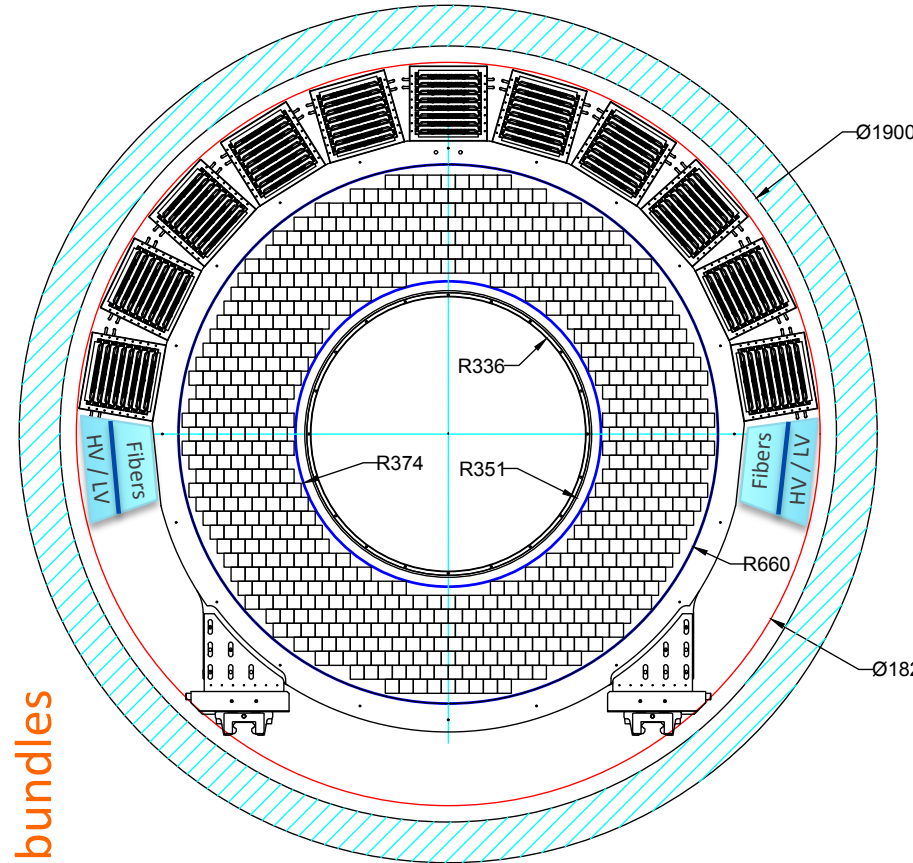
- 2 HV/LV/Fiber Box will be located at  $\pm 7^\circ$  in  $\phi$ .
- 1 serving the Top area, 1 serving the Bottom area
- Each sphere will have 1 input and 3 output fiber bundles (225 total), serving 170 crystals+ 1 PIN Diode

33 cm



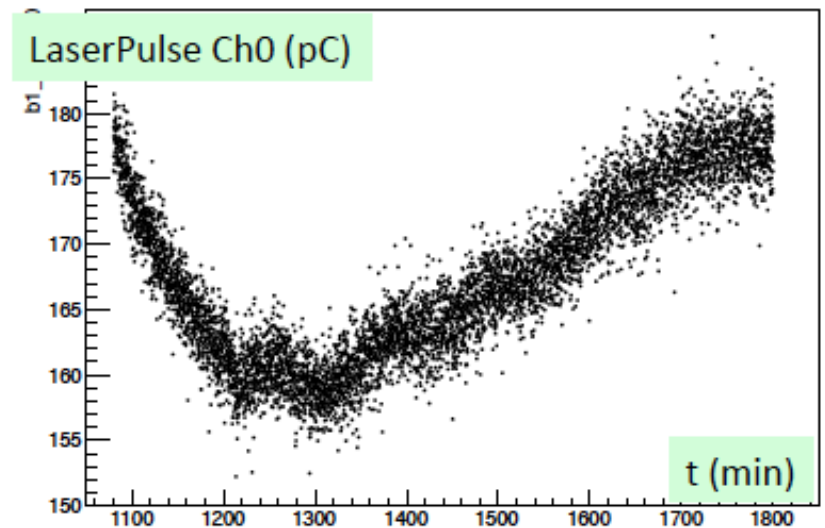
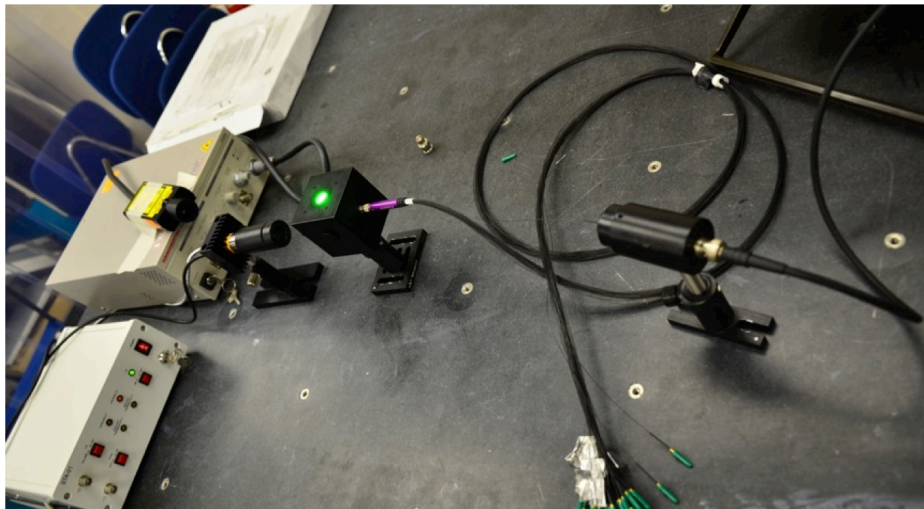
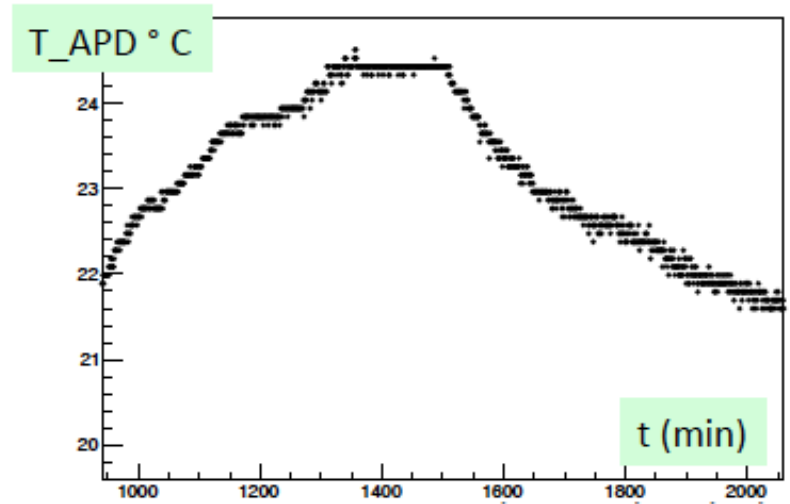
Output bundles

Input fibers



# Performance – Laser System Prototype

- A prototype of the laser system (below) was used to study, e.g., laser pulse stability.
- The plots (right) show the anti-correlation between temperature and APD gain, as well as the  $\sim 5\%$  pulse-to-pulse variation.



# Prototype system performance @ LYSO test beam for timing

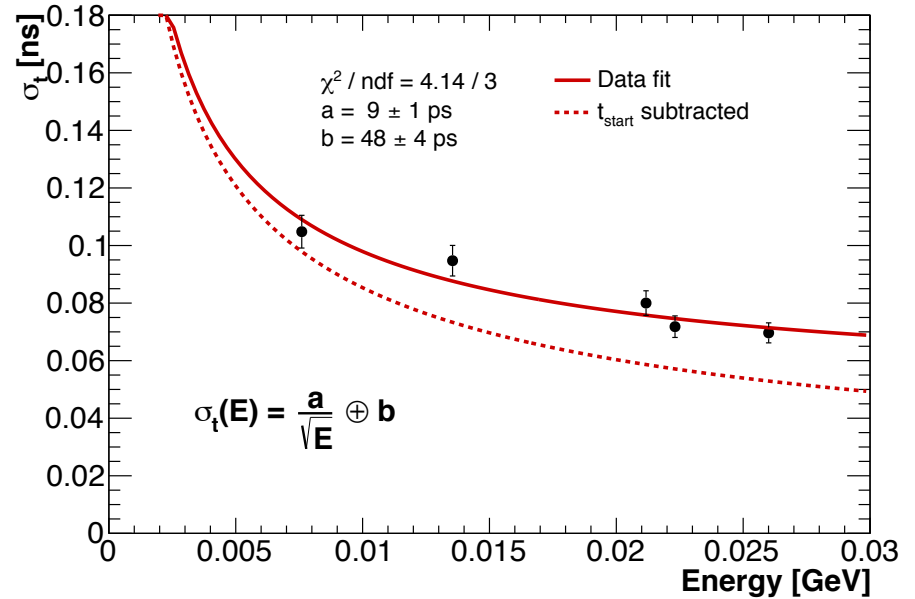
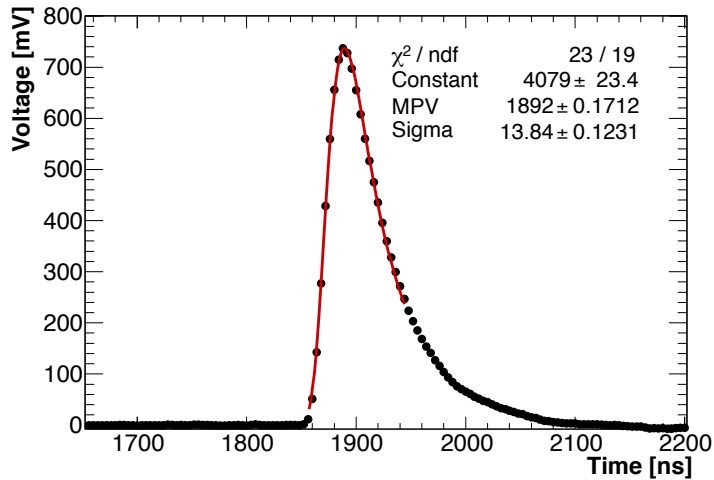


Figure 13: Time resolution for laser signals as a function of the equivalent deposited energy.

# Environment, Safety & Health

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- Radiation (Mu2e HAR: DocDB 675)
  - The DT generator is a radiation-producing device that must be licensed and appropriately shielded for safe operation
  - Bunker design for generator installation at FNAL has been simulated using MARS, acceptable levels of radiation in accessible areas. Survey with fluid to be performed
  - We have California licensing for operation of the DT generator at Caltech, and radiation survey records
  - **Light flasher laser will be appropriately enclosed**
  - Residual activity of the fluid is suppressed by its 7 s half-life
- Electrical
  - DT generator operates at ~100 kV, standard HV precautions and interlocks will apply. Under keyed control
- Chemical
  - The source calibration working fluid is Fluorinert™ FC-770, will be protected from accidental release to the environment

# Points to be addressed

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- **LASER Choice:**
  - Compromise between Pulse Energy and distribution system
  - Maximum repetition rate
  - Long term reliability and duration of Laser Head ?
- **Safety Class for LASER and Laser HUT**
- Primary optical distribution and PIN-Diode selection for Monitoring
- **Laser Wheel:** Model Home-made or COTS (Comm. Off the Shelves)?
- PIN diode resistance to radiation and change of response with temperature.
- Integrating Sphere under Vacuum? Problems?
  - Pro/contra of Diffusers ? Dimension and technical Specs?